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Date:	October 3, 2005	Fax:	571-273-8300
To:	U.S. Patent and Trademark Office	Phone:	

**Special Processing Submission
Mail Stop Petition
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450**

From:	David C. Hsia
Serial No.:	10/779,952
Docket:	ANS-P105
Re:	Petitions
Pages:	12 (including cover sheet)

Message:

Re: Applicant(s): Yee-Chung Fu
Assignee: Advanced Nano Systems, Inc.
Title: MEMS Scanning Mirror with Trenched surface and Tapered Comb
Teeth for Reducing Inertia and Deformation
Serial No.: 10/779,952
Examiner: Allan R. Wilson
Docket No.: ANS-P105

Filed: February 13, 2004
Group Art Unit: 2815

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Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) This facsimile transmittal (1 page);
- (2) Transmittal Letter (1 page);
- (3) Credit Card Payment Form PTO-2038 (1 page);
- (4) Petition Under 37 C.F.R. § 1.137(b) to Revive and Unintentionally Abandoned Application (3 pages);
- (5) Petition Under 37 C.F.R. § 1.313(c)(2) to Withdraw an Application from Issue (2 pages);
- (6) Request for Continued Examination (RCE) Under C.F.R. § 1.114 (1 page);
- (7) Amendment (3 pages).

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Brian D. Oganowsky
Carmen C. Cook
David C. Hsia
Rachel V. Leiteman

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- ☐ No additional fee is required.
- ☒ The fee has been calculated as shown below:
- | | | |
|---|----------|-----------------|
| <input checked="" type="checkbox"/> Fee for Petition to Revive | \$ | 750.00 |
| <input checked="" type="checkbox"/> Fee for Petition to Withdraw an Application from Issue | \$ | 130.00 |
| <input checked="" type="checkbox"/> Fee for Request for Continued Examination (RCE) | \$ | 395.00 |
| <input checked="" type="checkbox"/> Please charge our credit card (Form PTO-2038 enclosed) in the amount of | Total \$ | <u>1,275.00</u> |
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I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.	
 Signature	10/3/05 Date

Respectfully submitted,



David C. Hsia
Attorney for Applicant(s)
Reg. No. 46, 245